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P/1596-77

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Takashi IZUTA et al.

Serial No.: 10/806,844

Filed: March 22, 2004

Confirmation No.: 2467

Date: October 18, 2005

Group Art Unit: 1765

Examiner: Mahmoud Dahimene

For: SUBSTRATE TREATING METHOD AND APPARATUS

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE

Sir:

In response to the Office Action dated October 4, 2005, the applicants reaffirm the election of the apparatus invention, claims 9-16, without traverse.

The applicants cannot agree with the Examiner's reference to "the invention of Izuta, claims 9-16," at page 2, penultimate line, since all of claims 1-16 represent inventions of Izuta.

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on October 18, 2005:

James A. Finder
Name of applicant, assignee or
Registered Representative
Signature
October 18, 2005
Date of Signature

Respectfully submitted,

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